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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Inventors: Akira NAKANO, et al.

Application No.: 10/574,858

Filed: April 6, 2006

For: HERMETIC COMPRESSOR AND MANUFACTURING METHOD
OF SUCTION MUFFLER

INFORMATION DISCLOSURE STATEMENT

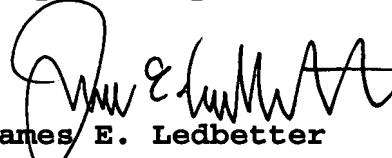
Assistant Commissioner of Patents
Washington, DC 20231

Dear Sir:

Pursuant to Rules 56 and 99, Applicants hereby call the attention of the Patent Office to the art listed on the attached Form PTO 1449.

Applicants present this art so that the Patent Office may, in the first instance, determine any relevancy thereof to the presently claimed invention, see Beckman Instruments, Inc. v. Chemtronics, Inc., 439 F.2d 1369, 1380, 165 USPQ 355, 364 (5th Cir. 1970). Also see Patent Office Rules 104 and 106. Applicants respectfully request that this art be expressly considered during the prosecution of this application and made of record herein and appear among the "References Cited" on any patent to issue herefrom.

Respectfully submitted,



James E. Ledbetter
Registration No. 28,732

Date: August 7, 2007

JEL/rew

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FORM PTO-1449 U.S. Department of Commerce (Rev. 4/92) Patent and Trademark Office	ATTY. DOCKET NO. L8638.06106	SERIAL NO. 10/574,858
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)		
E IAP97  APPLICANT Akira NAKANO, et al.		
FILING DATE April 6, 2006 GROUP 3748		

~~SEARCHED~~ & ~~INDEXED~~ PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation is considered, draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.